

2016 International Workshop on EUV Lithography (EUVL Workshop)

June 13-16, 2016, The Center for X-Ray Optics (CXRO),
Lawrence Berkeley National Laboratory, Berkeley, CA

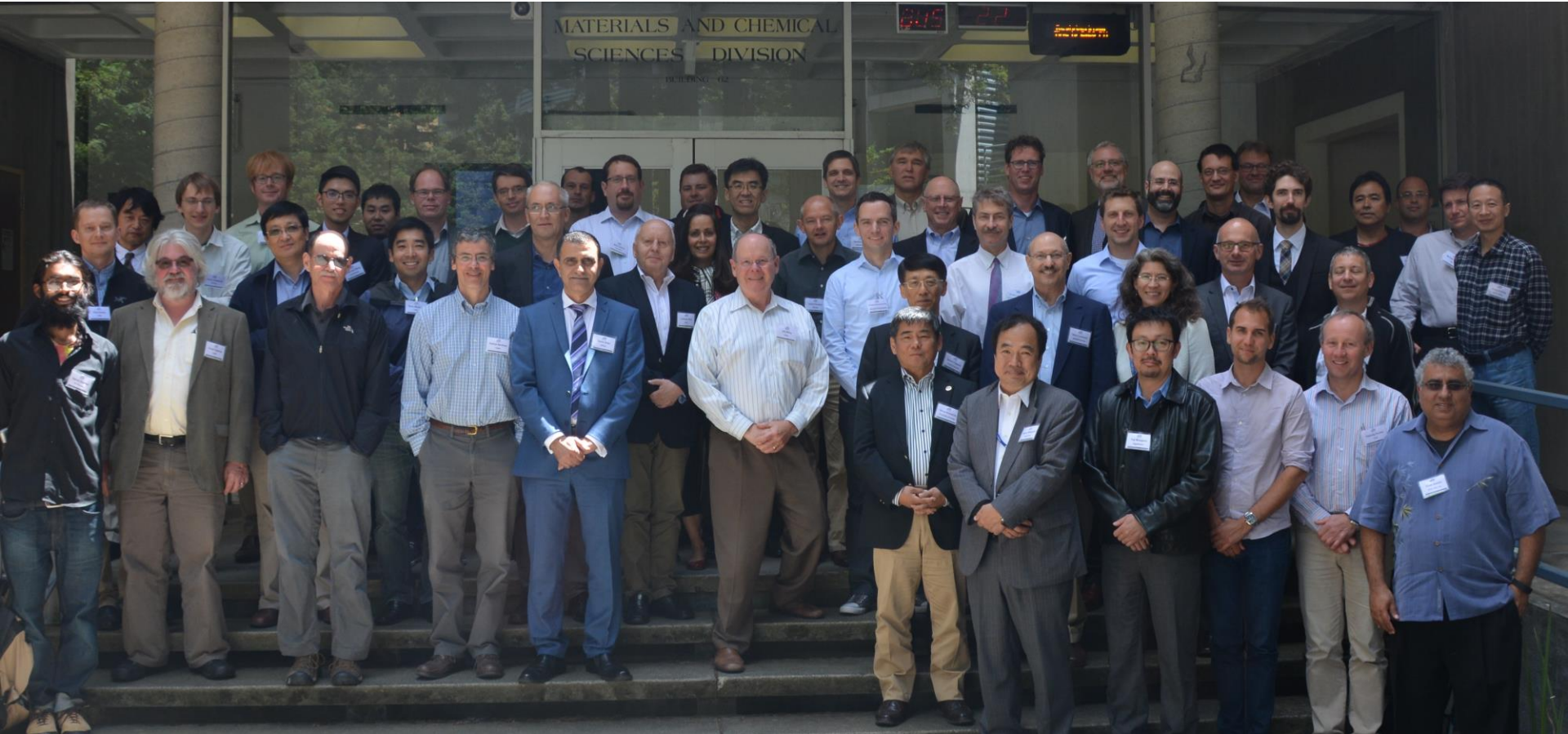
Workshop Photographs



Workshop Photographs

- Group Photograph
- Keynote Awards
- Best Poster Award
- Reception & Poster Session
- Area photographs

2016 EUVL Workshop Group Photograph



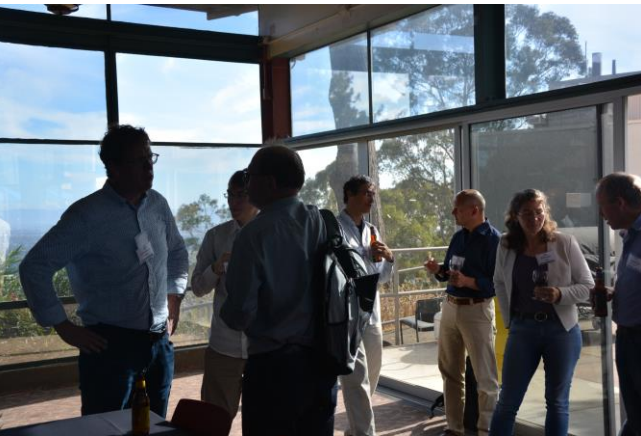
Keynote Presentation Awards



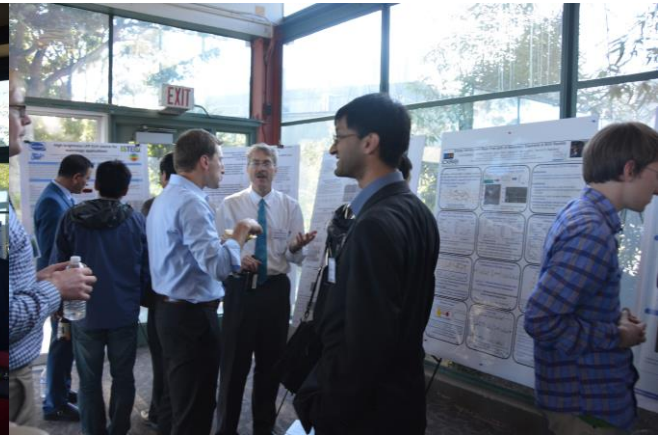
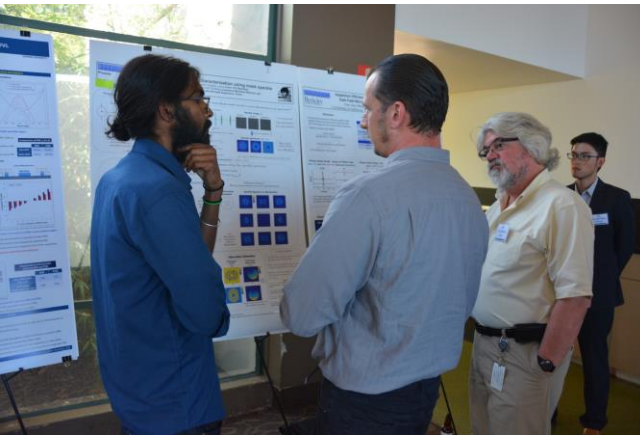
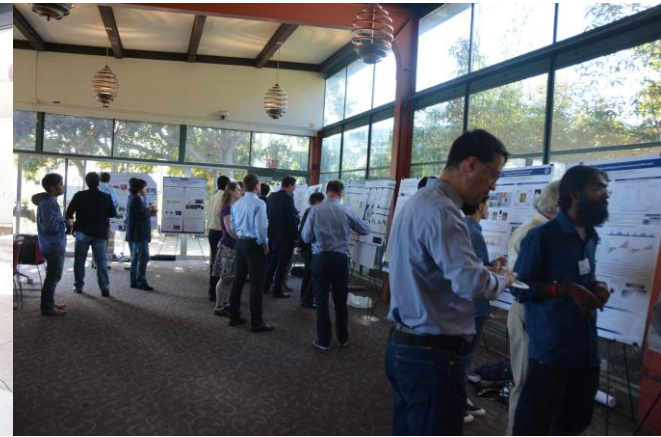
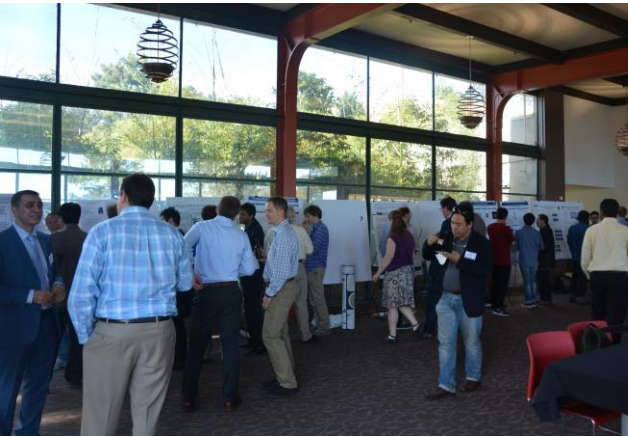
Best Poster Award



Reception



Poster Session



Dinner



AREA PHOTOGRAPHS





